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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/534,695	05/13/2005	Masashi Nakamura	1592-0155PUS1	8694
2292 BIRCH STEW	7590 04/30/200 ART KOLASCH & BI	EXAMINER		
PO BOX 747			HARRISON, MONICA D	
FALLS CHURCH, VA 22040-0747			ART UNIT	PAPER NUMBER
			2813	
			<u>,</u>	
SHORTENED STATUTOR	Y PERIOD OF RESPONSE	NOTIFICATION DATE	DELIVERY MODE	
3 MONTHS		04/30/2007	ELECTRONIC	

Please find below and/or attached an Office communication concerning this application or proceeding.

If NO period for reply is specified above, the maximum statutory period will apply and will expire 6 MONTHS from the mailing date of this communication.

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Office Action Summary The MAILING DATE of this communication appeared for Reply	LY IS SET TO EXPIRE <u>3</u> MC	NAKAMURA ET AL. Art Unit 2813 h the correspondence address
The MAILING DATE of this communication a	Monica D. Harrison opears on the cover sheet with	2813
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	LY IS SET TO EXPIRE <u>3</u> MC	h the correspondence address
A SHORTENED STATUTORY PERIOD FOR REP WHICHEVER IS LONGER, FROM THE MAILING - Extensions of time may be available under the provisions of 37 CFR 1 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory perior Failure to reply within the set or extended period for reply will, by statu. Any reply received by the Office later than three months after the mail earned patent term adjustment. See 37 CFR 1.704(b).	.136(a). In no event, however, may a red d will apply and will expire SIX (6) MONT tte, cause the application to become ABA	ATION. ply be timely filed HS from the mailing date of this communication. ANDONED (35 U.S.C. § 133).
Status		
1)⊠ Responsive to communication(s) filed on <u>08</u> 2a)⊠ This action is FINAL . 2b)□ Th 3)□ Since this application is in condition for allow closed in accordance with the practice under	is action is non-final. ance except for formal matte	
Disposition of Claims		
4) ⊠ Claim(s) 10-27 is/are pending in the applicat 4a) Of the above claim(s) is/are withdr 5) □ Claim(s) is/are allowed. 6) ⊠ Claim(s) 10-27 is/are rejected. 7) □ Claim(s) is/are objected to. 8) □ Claim(s) are subject to restriction and	awn from consideration.	
Application Papers		
9) The specification is objected to by the Examination The drawing(s) filed on is/are: a) and according a deposition of the drawing sheet (s) including the correct that any objection to the Replacement drawing sheet (s) including the correct that any objected to by the left that are considered to be the left that are considered that are considered to be the left that are considered to be the	ccepted or b) objected to be drawing(s) be held in abeyand ection is required if the drawing(s)	ce. See 37 CFR 1.85(a). s) is objected to. See 37 CFR 1.121(d).
Priority under 35 U.S.C. § 119		
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority docume 2. Certified copies of the priority docume 3. Copies of the certified copies of the prapplication from the International Bure * See the attached detailed Office action for a limit	nts have been received. nts have been received in Apiority documents have been real (PCT Rule 17.2(a)).	oplication No received in this National Stage
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date	Paper No(s	ummary (PTO-413))/Mail Date formal Patent Application

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DETAILED ACTION

1. Applicant's arguments and remarks filed 11/8/06 have been entered.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 10-27 are rejected under 35 U.S.C. 102(b) as being anticipated by Oida et al (5,647,917).

- 2. Regarding claim 10, Oida et al discloses an epitaxial growth method comprising: supporting a substrate for growth with a substrate supporter (Figure 2, support is the lower substrate), forming a compound semiconductor layer comprising 3 or 4 elements on the substrate (Figure 2) for growth by metal organic chemical vapor deposition (column 1, lines 27-34), polishing the substrate (column 5, line 44) so that an angle of gradient is 0.000 to 0.030 or 0.040 to 0.100 with respect to (100) direction in an entire effective area of the substrate (column 6, lines 52-67 thru column 7, lines 1-40), and forming the compound semiconductor layer to be 0.5 µm thick or more on the substrate by using the substrate for growth (Figure 2).
- 3. Regarding claim 11, Oida et al discloses forming a buffer layer on the substrate for growth, and forming the compound semiconductor layer on the buffer layer (Figure 2, *InP*).
- 4. Regarding claim 12, Oida et al discloses wherein the compound semiconductor layer is a III-V group compound semiconductor layer containing at least As (Figure 2, *InGaAs*).

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5. Regarding claim 13, Oida et al discloses wherein the compound semiconductor layer is a III-V group compound semiconductor layer containing at least As (Figure 2, *InGaAs*).

- 6. Regarding claim 14, Oida et al discloses wherein the compound semiconductor layer is an InGaAs layer or an lnAlAs layer (Figure 2, *InGaAs*).
- 7. Regarding claim 15, Oida et al discloses wherein the compound semiconductor layer is an InGaAs layer or an InAlAs layer (Figure 2, *InGaAs*).
- 8. Regarding claim 16, Oida et al discloses wherein the substrate for growth is a semiconductor crystal substrate having dislocation density of 5000cm⁻² or less (column 6, lines 52-67 thru column 7, lines 1-40).
- 9. Regarding claim 17, Oida et al discloses wherein the substrate for growth is a semiconductor crystal substrate having dislocation density of 5000cm⁻² or less (column 6, lines 52-67 thru column 7, lines 1-40).
- 10. Regarding claim 18, Oida et al discloses wherein the substrate for growth is a semiconductor crystal substrate having dislocation density of 5000cm⁻² or less (column 6, lines 52-67 thru column 7, lines 1-40).
- 11. Regarding claim 19, Oida et al discloses wherein the substrate for growth is a semiconductor crystal substrate having dislocation density of 5000cm⁻² or less (column 6, lines 52-67 thru column 7, lines 1-40).
- 12. Regarding claim 20, Oida et al discloses wherein the substrate for growth is an InP substrate (Figure 2, *InP*).
- 13. Regarding claim 21, Oida et al discloses wherein the substrate for growth is an InP substrate (Figure 2, *InP*).

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14. Regarding claim 22, Oida et al discloses wherein the substrate for growth is an InP substrate (Figure 2, *InP*).

- 15. Regarding claim 23, Oida et al discloses wherein the substrate for growth is an InP substrate (Figure 2, *InP*).
- 16. Regarding claim 24, Oida et al discloses a substrate for epitaxial growth used for an epitaxial growth method in which a compound semiconductor layer comprising 3 or 4 elements is formed on the substrate for growth (Figure 2) by metal organic chemical vapor deposition (column 1, lines 27-34), wherein an angle of gradient is 0.000 to 0.030 or 0.040 to 0.100 with respect to (100) direction in an entire effective area of the substrate (column 6, lines 52-67 thru column 7, lines 1-40).
- 17. Regarding claim 25, Oida et al discloses wherein the substrate is a semiconductor crystal substrate having dislocation density of 5000cm⁻² or less (column 6, lines 52-67 thru column 7, lines 1-40).
- 18. Regarding claim 26, Oida et al discloses wherein the substrate is an InP substrate (Figure 2, *InP*).
- 19. Regarding claim 27, Oida et al discloses wherein the substrate is an InP substrate (Figure 2, *InP*).

Response to Arguments

20. Applicant's arguments filed 11/8/06 have been fully considered but they are not persuasive. Applicant states that Oida '917 does not explicitly or implicitly disclose that the compound semiconductor layer is formed to a thickness of 0.5μm or more. Examiner disagrees. In column 7, lines 1-36, Oida et al discloses an InP layer (compound semiconductor layer)

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epitaxially formed at a growth rate of 0.05μm/hr and 20 μm/hr. 0.5μm or more falls within this range. To say Oida '917 is not concerned with the problem of aberrant surface morphology which occurs when the compound semiconductor layer is formed to be 0.5μm thick or more, aberrant surface morphology is not within the claimed subject matter therefor, it is not considered. Applicant also states Oida '917 fails to disclose or suggest the use of a substrate not having a certain plane orientation in the entire area of the substrate, specifically, between 0.03° and 0.04°, also is not in the claimed subject matter. The angle of gradient is 0.00° to 0.03° or 0.04° to 0.10° as claimed. Plane orientation is found within column 7, lines 1-52.

Conclusion

21. THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Monica D. Harrison whose telephone number is 571-272-1959. The examiner can normally be reached on M-F 7:00am-3:30pm.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl Whitehead Jr. can be reached on 571-272-1702. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Monica D. Harrison AU 2813

mdh April 17, 2007

CAPL WHITEHEAD, JP.
SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 2800